

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Woo Sik Yoo
Assignee: WaferMasters, Inc.
Title: Method for H2 Recycling In Semiconductor Processing System
Serial No.: 09/828,518 Filing Date: April 6, 2001
Examiner: Olivia T. Luk Group Art Unit: 2812
Docket No.: M-8608US

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August 21, 2002

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COMMISSIONER FOR PATENTS
Washington, D. C. 20231

RESPONSE TO NOTICE OF RESTRICTION REQUIREMENT

Dear Sir:


In response to the Restriction Requirement dated June 27, 2002, Applicant(s) hereby elect to prosecute Group I, Claims 1-7. Applicant reserves the right to prosecute non-elected Claims 8-15, in a divisional application. If the Examiner has any questions, please call the undersigned at (949) 752-7040.

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on August 21, 2002.


Sandy Kim

August 21, 2002
Date of Signature

Respectfully submitted,


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